



ITW

Docket No.: 071971-0251

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 53080  
Makoto KITABATAKE, et al. : Confirmation Number: 6640  
Application No.: 10/536,828 : Group Art Unit: 2814  
Filed: May 27, 2005 : Examiner: Abul KALAM  
  
For: SEMICONDUCTOR APPARATUS INCLUDING POWER SEMICONDUCTOR DEVICE  
CONSTRUCTED BY USING WIDE BAN GAP SEMICONDUCTOR

**INFORMATION DISCLOSURE STATEMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

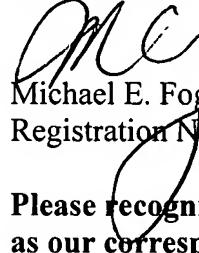
This Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits. No certification or fee is required.

The references were cited in a corresponding Chinese Office Action and their relevance discussed therein. A copy of the Chinese Office Action, together with an English language version thereof, is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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**Date: October 26, 2007**